

XA-10625

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

TERANO, Akihisa et al.

Intl. Appln. No.: PCT/JP2004/011219

Intl. Filing Date: 29 July 2004

For: CAPACITANCE TYPE MEMS DEVICE, MANUFACTURING METHOD
THEREOF, AND HIGH FREQUENCY DEVICE

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PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Attn: Mail Stop PCT, DO/EO/US

Sir:

Prior to examination, please amend the above-identified patent application as indicated below.

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begin on page 7 of this paper.

Remarks begin on page 13 of this paper.